## ALTERNATIVE TO PTO/SB/08e/b (06-03)

Substitute for form 1449/PTO				Complete if Known	
"				Application Number	10/537,804
INFORMATION DISCLOSURE				Filing Date	June 7, 2005
l s	TATEMENT I	3Y /	APPLICANT	First Nemed Inventor	Robert DWILINSKI
-				Art Unit	Not yet assigned 1792
(Use as many sheets as necessary)				Examiner Neme	Not yet assigned. /Fellsa Hiteshaw/
Sheet	1	of	1	Attorney Docket Number	204552035400

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U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.1	Document Number Number-Kind Code <sup>2</sup> (# known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	1.	5,306,662	4-26-1994	Nakamura et al.	

FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No.1	Foreign Patent Document  Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>6</sup> (# known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
intodas -			7-23-1993		abstract, also	H	
	2.	JF-5-163169	7-23-1993		corresponds to		
					U.S. Patent No.		
					5,306,662	$\perp$	

EXAMINER: Initial information considered, whether or not classion is in conformance with MPEP 609. Draw line through classion if not in conformance act in the considered, include copy of this form with noted communication is opplicant. \*\*Applicant's unique classion designation market or jointee.\*\*See the conformation of the

NON PATENT LITERATURE DOCUMENTS					
Examiner Initials	Cite No.1				
	3.	M. K. Kelly et al. (1996) "Optical Patterning of GaN Films," Appl Phys. Lett 69(12), pp. 1749- 1751			
	4.	W. S. Wong et al. (1999) *Fabrication of Thin-Film InGaN Light-Emitting Diode Membranes By Laser Lift-Off," Applied Physics Letters 75(10), pp. 1360-1362			
	5.	S. Porowski et al. (1993) "Prospects for High-Pressure Crystal Growth of III-V Nitrides," Inst. Phys. Conf. Ser. No. 137, Chapter 4, pp. 369-372			

<sup>\*</sup>EXAMINER: Initial if information considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Examiner	/Felisa Hiteshew/	Date	04/18/2008
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<sup>&</sup>lt;sup>1</sup>Applicant's unique citation designation number (optional). <sup>1</sup>Applicant is to place a check mark here if English languaga Translation is attached.